



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 29, 2026	
IGI Report Number	LG769665915
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.29 - 9.31 X 5.79 MM

GRADING RESULTS

Carat Weight	3.08 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

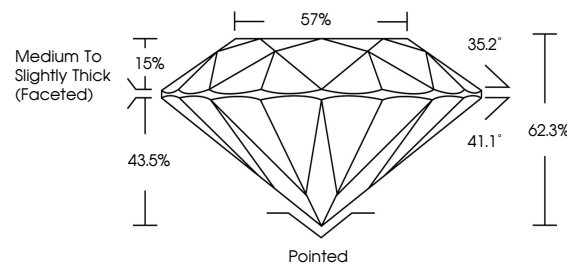
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG769665915

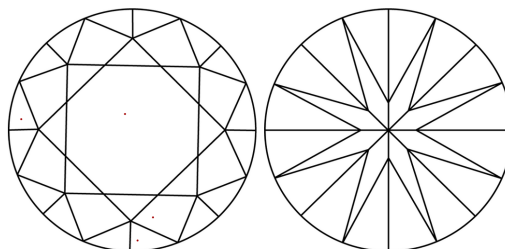
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG769665915
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

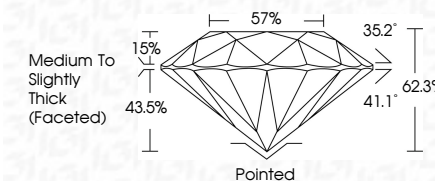
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



January 29, 2026	
IGI Report Number	LG769665915
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.29 - 9.31 X 5.79 MM

GRADING RESULTS

Carat Weight	3.08 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG769665915
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES

www.igi.org

January 29, 2006
GL Report No LG749665915

ROUND BRILLIANT
G-29 - 6.31 X 5.79 MM
Carat Weight
Color Grade
Clarity Grade
Cut Grade
Depth
Table
Girdle
Medial Thickness
Medium
Tuck
169 Lbs

Comments:
Chemically Grown Diamond
treated by Chemical Vapor
Deposition (CVD) growth process.
Type Ila